



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appln. of: Kenichi Mitsumori ET AL.

Appln. No.: 10/801,476

Filed: March 16, 2004

For: ULTRASONIC VIBRATOR,
WET-TREATMENT NOZZLE,
AND WET-TREATMENT
APPARATUS

Attorney Docket No: 9281-4823

Examiner: Not yet assigned

Art Unit: 1746

INFORMATION DISCLOSURE STATEMENT

In accordance with the duty of disclosure under 37 C.F.R. §1.56 and §§1.97-1.98, and more particularly in accordance with 37 C.F.R. §1.97(b), Applicants hereby cite the following reference(s):

No.	Date of Publication	Patentee/Applicant/Assignee
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FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER <small>Number-Kind Code (if known)</small>	DATE	COUNTRY
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OTHER ART - NON PATENT LITERATURE DOCUMENTS

"Advanced Wet Cleaning Using Novel Nozzle and Functional Ultrapure Water in Next Generation FPD/LSI Manufacturing;" Ken-ichi Mitsumori et al; The Ninth International Symposium on Semiconductor Manufacturing; Tokyo, Japan